

O2/01

GAU 179

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

PATEL et al.

Serial No.:

09/649,569

Group Art Unit:

1746

Filed:

August 28, 2000

Examiner:

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For.

APPARATUS AND METHOD FOR FLOW OF PROCESS GAS IN AN ULTRA-CLEAN

**ENVIRONMENT** 

## INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)

Assistant Commissioner of Patents Washington, D.C. 20231

December 28, 2000

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-08A/B (substitute for Form 1449A/B). Copies of the references are enclosed.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the last of (1) issuance of a first official action on the merits and (2) expiration of the three month period following filing of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can determine any materiality thereof to the claimed invention. It is respectfully requested that the information be considered during the prosecution of this application and that the cited documents be listed on the front page of any patent issuing from this application.

The Patent Office is authorized to charge our Deposit Account No. 501516 for any fee which it deems to be required to effect consideration of this statement.

Respectfully submitted,

Gregory B. Muir

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